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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/646,508	08/22/2003	Junichi Aoyama	09792909-5680	9683	
75	90 02/12/2004	EXAMINER			
SONNENSCHEIN NATH & ROSENTHAL			NGUYEN, DILINH P		
Wacker Drive Station - Sears Tower P.O. Box 061080			ART UNIT	PAPER NUMBER	
Chicago, IL 6	- -	2814			
			DATE MAILED: 02/12/200	4	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application	No.		Applicant(s)	7-11-			
Office Action Summary		10/646,508	3		AOYAMA ET AL.				
		Examiner			Art Unit				
		DiLinh Ngu			2814				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply									
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM									
THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b). Status									
1) 🖂	Responsive to communication(s) filed on 2	22 August 2003							
2a)□	•	This action is r		al.					
3)□	- 15. So well another proposition as to the morits is								
Dispositi	closed in accordance with the practice und on of Claims	ger <i>⊏x parte Qu</i>	iayie, i	900 C.D. 11, 4	33 O.G. 210.				
4) Claim(s) 5-13 is/are pending in the application.									
4a) Of the above claim(s) is/are withdrawn from consideration.									
5)	5) Claim(s) is/are allowed.								
6)⊠	6)⊠ Claim(s) <u>5-13</u> is/are rejected.								
•	Claim(s) is/are objected to.								
ľ	Claim(s) are subject to restriction an	nd/or election re	quirem	ent.					
Application Papers									
9) The specification is objected to by the Examiner.									
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).									
Applicant may not request that any objection to the drawing(s) be field in abeyance. Get of of the model. 11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.									
''/_	If approved, corrected drawings are required in								
12)☐ The oath or declaration is objected to by the Examiner.									
l '	ınder 35 U.S.C. §§ 119 and 120								
13)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).									
	a)⊠ All b)□ Some * c)□ None of:								
	1.⊠ Certified copies of the priority documents have been received.								
	2. Certified copies of the priority documents have been received in Application No								
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.									
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).									
a) The translation of the foreign language provisional application has been received. 15) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.									
Attachment(s)									
1) Notice	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948 mation Disclosure Statement(s) (PTO-1449) Paper No	3) o(s)	5) 🔲	Interview Summar Notice of Informal Other:	y (PTO-413) Paper N Patent Application (P	lo(s) TO-152)			

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DETAILED ACTION

Specification

The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed.

Drawings

Figures 9A-10B should be designated by a legend such as --Prior Art-- because only that which is old is illustrated. See MPEP § 608.02(g). A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 2. Claims 5, 7-8, 10-11 and 13 are rejected under 35 U.S.C. 102(e) as being anticipated by Clevenger et al. (U.S. Pat. 6255712).
 - Regarding claims 5, 8 and 11, Clevenger et al. disclose a semiconductor device comprising :

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forming a wiring and a filing layer 16 filling between wirings 11 on a substrate 0 (fig. 7);

forming a gas permeable film 15 on the wiring and the filling layer (fig. 9); removing the filling layer through the gas permeable film so as to form a gap between the wirings;

filling a gas having a thermal conductivity equal to or higher than three times that of air at 0°C through the gas permeable film into the gap (fig. 9, column 3, lines 32-41 and column 5, lines 49-66); and

forming a gas impermeable film 19 (fig. 9) on the gas permeable film.

 Regarding claims 7, 10 and 13, Clevenger et al. disclose wherein the gas is one of helium gas (column 3, line 37).

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 6, 9 and 12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Clevenger et al. (U.S. Pat. 6255712) in view of Xia et al. (U.S. Pat. 6472333).

Clevenger et al. fail to disclose the gas impermeable film is made of silicon nitride.

Xia et al. disclose a silicon carbide cap layer is permeable, wherein a low dielectric constant insulating material include silicon dioxides (column 1, lines 39-40)

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and a gas impermeable film is made of silicon nitride (column 1, lines 49-55).

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the device of Clevenger et al. to increase the device functionality for a semiconductor package, as shown by Xia et al.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to DiLinh Nguyen whose telephone number is (571) 272-1712. The examiner can normally be reached on 8:00AM - 6:00PM (M-F).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on (571) 272-1705. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

DLN February 8, 2004

SUPERVISORY PRIMARY EXAMINER